

OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/810,387
Confirmation No.....8779
Filing Date March 15, 2001
Inventor..... Craig M. Carpenter
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1763
Examiner R. Zervigon
Attorney's Docket No.MI22-1559
Customer No.021567
Title: Chemical Vapor Deposition Apparatuses and Deposition Methods

RESPONSE TO NOVEMBER 12, 2003 OFFICE ACTION

To:

Commissioner for Patents
PO Box 1450
Art Unit 1763
Alexandria, VA 22313

From:

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AMENDMENTS

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